



THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Daniel Alvarez, Jr. and Jeffrey J. Spiegelman

Application No.: 10/692,018 Group: 1724

Filed: October 23, 2003 Examiner: Unknown

Confirmation No.: 8519

For: METHOD FOR PURIFICATION OF LENS GASES USED
IN PHOTOLITHOGRAPHY

CERTIFICATE OF MAILING OR TRANSMISSION	
I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as First Class Mail in an envelope addressed to Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, or is being facsimile transmitted to the United States Patent and Trademark Office on:	
4/23/04	Linda Woodhouse
Date	Signature
LINDA WOODHOUSE	
Typed or printed name of person signing certificate	

PRELIMINARY AMENDMENT

Mail Stop Missing Parts
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Please amend the application as follows: